



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Shuichi Kikuchi et al. Art Unit : 2813
Serial No. : 10/651,855 Examiner : Thanh Nguyen
Filed : August 29, 2003
Title : SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING IT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF NOVEMBER 24, 2004

Please amend the above-identified application as follows:

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Feb - 24, 2005
Date of Deposit
Paula J. Romero
Signature

Typed or Printed Name of Person Signing Certificate